Form PTO-1449 U.S. DEPARTMENT_OF COMMERCE ATTY, DOCKET NO. SERIAL NO. MI22-1689 PATENT AND TRADEMARK OFFICE Unknown LIST OF ART CITED BY APPLICANT APPLICANT Luan C. Tran (Use several sheets if necessary) FILING DATE **GROUP** Filed herewith Filed herewith U.S. PATENT DOCUMENTS Subclass Class Filing Date If Appropriate *Examiner Date Document Name Number Initial AΑ 4,612,629 09/16/86 Harari ΑB 4,785,342 11/15/88 Yamanaka et al. AC 5,786,249 07/28/98 Dennison AD 6,074,924 06/13/00 Dennison et al. ΑE 5,272,367 12/21/93 Dennison et al. ΑF 6,004,854 12/21/99 Dennison et al. AG 5,683,927 11/04/97 Dennison et al. ΑH 6,124,616 09/26/00 Dennsion et al. 5,747,855 05/05/98 Dennison et al. ΑJ 5,534,449 07/09/96 Dennison et al.) AK 5,7706,806 07/07/98 Dennison et al. 5,773,863 AL 06/60/98 Burr et al. FOREIGN PATENT DOCUMENTS Date Class Subclass Translation Document Country Number No Yes EP 0 717 448 A1 06/19/96 **EPO** AN WO 98/29897 07/09/98 PCT ΑO OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.) Silicon Processing for the VLSI Era, Vol. III; "Punchthrough (Subsurface-DIBL) in Short-Channel MOSFETs"; undated; pp. 232-235, 238-244 AR AS **EXAMINER** DATE CONSIDERED *EXAMINER: Initial if reference considered, whether or not offation is a conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applican